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SERIAL NUMBER 09/812,365	FILING DATE 03/20/2001 RULE	CLASS 703	GROUP ART UNIT 2123	ATTORNEY DOCKET NO. PW 024 5694	
APPLICANTS Naoki Kusunoki, Tokyo, JAPAN; Nobutoshi Aoki, Kanagawa-ken, JAPAN; Hirotaka Amakawa, Kanagawa-ken, JAPAN; <i>M.S.</i>					
** CONTINUING DATA ***** <i>NONE</i> <i>M.S.</i>					
** FOREIGN APPLICATIONS ***** JAPAN P2000-85268 03/24/2000 <i>M.S.</i>					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/26/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <input checked="" type="checkbox"/> allowance Verified and <i>Mina Shindoh, M.S.</i> Acknowledged <i>Examiner's Signature</i> Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 23	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
ADDRESS Mr. Roger R. Wise PILLSBURY MADISON & SUTRO LLP Suite 1200 725 South Figueroa Street Los Angeles, CA 90017					
TITLE Method of simulation of production process of semiconductor device and simulator thereof					
FILING FEE RECEIVED 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		